## Amendments to the Claims:

A listing of the entire set of pending claims (including amendments to the claims, if any) is submitted herewith per 37 CFR 1.121. This listing of claims will replace all prior versions, and listings, of claims in the application.

## **Listing of Claims:**

- 1. (Currently Amended) A method of irradiating a surface (L1, L2) comprising a photosensitive layer (L2) on a substrate (L1) and (L2) comprising a photosensitive layer and, wherein the surface (L1, L2) is immersed in an immersion fluid (L3), the method comprising: [[-]] applying a removable protective transparent layer (L4) [[(L4, L5)]] to the surface (L1, L2), wherein the removable protective transparent layer (L4) serves to space apart the surface (L1, L2) from the immersion fluid (L3),
- [[-]] projecting electromagnetic radiation onto the <u>photosensitive layer (L2) of the</u> surface (L1, L2) through the immersion fluid (L3) and through the <u>removable protective</u> transparent layer (L4), and
- [[-]] subsequently removing the <u>removable protective</u> transparent layer (<u>L4</u>).
- 2. (Currently Amended) The method of claim 1, wherein the projecting comprises projecting a pattern onto the photosensitive layer (L2).
- 3. (Currently Amended) The method of claim 2, wherein the photosensitive layer (L2) is a resist layer (L2) and the projecting comprises projecting a pattern to pattern the resist layer (L2) to form a patterned resist layer (L2).
- 4. (Currently Amended) The method of claim 3, further comprising a step of using the patterned resist layer (L2) as a mask in a further lithographic step.
- 5. (Currently Amended) The method according to claim 1, wherein the thickness of the removable <u>protective</u> transparent layer (<u>L4</u>) is such that imperfections in the immersion fluid are out of focus as projected on the surface.

- 6. (Currently Amended) The method of claim 2, wherein the step of the removal of the removable protective transparent layer (L4) precedes or is combined with a step of developing the photosensitive layer (L3).
- 7. (Currently Amended) The method of claim 1, the <u>removable protective</u> transparent layer (<u>L4</u>) being removed by dissolving with a dissolving fluid.
- 8. (Currently Amended) The method according to claim 7, wherein the dissolving fluid is used for developing the photosensitive layer (L3).
- 9. (Currently Amended) The method of claim 1 comprising a step of altering the solubility of the <u>removable protective</u> transparent layer (<u>L4</u>) after the immersion in the immersion fluid.
- 10. (Currently Amended) The method of claim 9, wherein the altering step further comprises the altering being carried out by a post exposure bake process.
- 11. (Currently Amended) The method of claim 9, wherein the altering step further comprises the altering being carried out by a flood exposure at a different wavelength to the wavelength of the radiation.
- 12. (Currently Amended) The method of claim 1, wherein the removable protective transparent layer (L4, L5) [[comprising]] comprises an upper (L5) and a lower layer (L4), the upper layer (L5) having an alterable solubility.
- 13. (Currently Amended) The method of claim 12, the lower layer (L4) having a filter function to protect the resist layer (L2) from the altering step.
- 14. 19. (Cancelled).